



18W  
PATENT  
790001-2034

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Noriaki Matsunaga et al.  
Serial No. : 10/628,689  
Filed : July 28, 2003  
For : **SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD**  
Examiner : Hoai V. Pham  
Art Unit : 2814

745 Fifth Avenue  
New York, NY 10151

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 28, 2004.

Bruno Polito, Reg. No. 38,580  
(Name of Applicant, Assignee or Registered Representative)

  
Signature

June 28, 2004

Date of Signature

**RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed May 26, 2004, setting a one-month period for reply and asserting a restriction requirement, Applicants request reconsideration and withdrawal of the restriction requirement in view of the following remarks. Further, Applicants submit the following claim amendments.